

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18
Stylesheet Version v18.0

3860
11-249
#15

Title of
Invention

METHOD OF DEPOSITING METAL FILM AND METAL
DEPOSITION CLUSTER TOOL INCLUDING
SUPERCRITICAL DRYING/CLEANING MODULE

Application Number: 09/841800
Confirmation Number: 6810
First Named Applicant: Maximilian Biberger
Attorney Docket Number:
Search string: (20030008238 or 20030008518 or
20030013311 or 20030036023 or
20030047533).pn.



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US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

| init | Cite.No. | Pub. No. | Date | Applicant | Kind | Class | Subclass |
|------|----------|-------------|------------|-----------------|------|-------|----------|
| | 1 | 20030008238 | 2003-01-09 | Goldfarb et al. | A1 | | |
| | 2 | 20030008518 | 2003-01-09 | Chang et al. | A1 | | |
| | 3 | 20030013311 | 2003-01-16 | Chang et al. | A1 | | |
| | 4 | 20030036023 | 2003-02-20 | Moreau et al. | A1 | | |
| | 5 | 20030047533 | 2003-03-13 | Reid et al. | A1 | | |

Remarks

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Signature

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| Examiner Name | Date |
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Electronic Filing System (EFS) Data
Electronic Patent Application Submission
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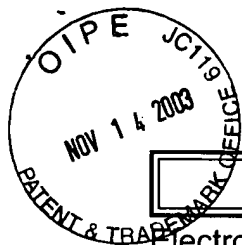
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Application ID: 09841800
Title of Invention: METHOD OF DEPOSITING METAL
FILM AND METAL DEPOSITION
CLUSTER TOOL INCLUDING
SUPERCRITICAL
DRYING/CLEANING MODULE
First Named Inventor: Maximilian Biberger
Domestic/Foreign Application: Domestic Application
Filing Date: 2001-04-24
Effective Receipt Date: 2003-11-14
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 6810
Attorney Docket Number: NONE



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Electronic Version v1.1

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| Application Number: 09/841800 | | RECEIVED NOV 18 2003 | | | | | | | | |
| Date: 2001-04-24 | | | | | | | | | | |
| First Named Applicant: Maximilian A. Biberger | | | | | | | | | | |
| Confirmation Number: 6810 | | | | | | | | | | |
| Attorney Docket Number: | | | | | | | | | | |
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| <table border="1"><tr><td>Submitted by:</td><td>Elec. Sign.</td><td>Sign. Capacity</td></tr><tr><td>Thomas B. Haverstock Registered Number: 32571</td><td>/tbh/</td><td>Attorney</td></tr></table> | | | Submitted by: | Elec. Sign. | Sign. Capacity | Thomas B. Haverstock Registered Number: 32571 | /tbh/ | Attorney | | |
| Submitted by: | Elec. Sign. | Sign. Capacity | | | | | | | | |
| Thomas B. Haverstock Registered Number: 32571 | /tbh/ | Attorney | | | | | | | | |
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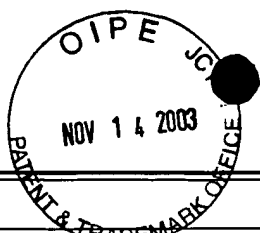
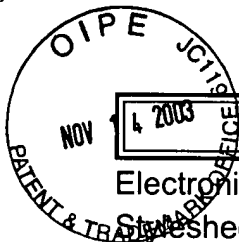
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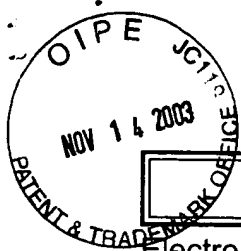
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| Submitted by: | Elec. Sign. | Sign. Capacity |
|--|-------------|----------------|
| Thomas B. Haverstock Registered Number: 32571 | /tbh/ | Attorney |

Documents being submitted
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Files
SSI02001D-usidst.xml
us-ids.dtd
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Comments



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or 6331487 or 6344243 or 6358673 or 6361696
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or 20020142595 or 20020150522 or
20030003762).pn.

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US Patent Documents

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| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
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| | 2 | 6255732 | 2001-07-03 | Yokoyama et al. | B1 | | |
| | 3 | 6270531 | 2001-08-07 | DeYoung et al. | B1 | | |
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| | 25 | 6558475 | 2003-05-06 | Jur et al. | B1 |
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| | 2 | 20010024247 | 2001-09-27 | Nakata | A1 | | |
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| | 19 | 20020141925 | 2002-10-03 | Wong et al. | A1 |
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| | 21 | 20020150522 | 2002-10-17 | Heim et al. | A1 |
| | 22 | 20030003762 | 2003-01-02 | Cotte et al. | A1 |

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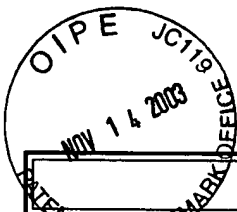
EFS ID: 50639
Application ID: 09841800
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Submission Type: Information Disclosure
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Filing Type:
Confirmation number: 6810
Attorney Docket Number: NONE



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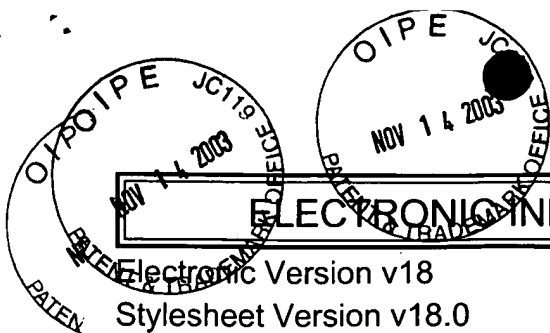
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Search string: (5807607 or 5847443 or 5872061 or 5893756
or 5896870 or 5904737 or 5992680 or 5994696
or 6001133 or 6005226 or 6037277 or 6063714
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US Patent Documents

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| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
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| | 1 | 5807607 | 1998-09-15 | Smith et al. | | | |
| | 2 | 5847443 | 1998-12-08 | Cho et al. | | | |
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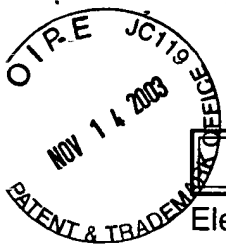
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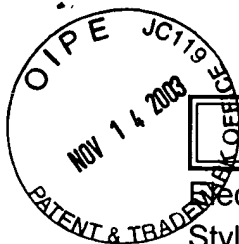


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| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
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| | 1 | 5370741 | 1994-12-06 | Bergman | | | |
| | 2 | 5714299 | 1998-02-03 | Combes et al. | | | |
| | 3 | 5725987 | 1998-03-10 | Combes et al. | | | |
| | 4 | 5736425 | 1998-04-07 | Smith et al. | | | |
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Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current electronic filing contains part 2 out of a total of 5 electronic filings. Fee has been paid in previous electronic filing.

Signature

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|---------------|------|
| Examiner Name | Date |
| | |



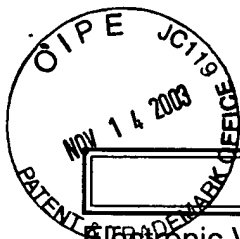
Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID: 50637
Application ID: 09841800
Title of Invention: METHOD OF DEPOSITING METAL
FILM AND METAL DEPOSITION
CLUSTER TOOL INCLUDING
SUPERCRITICAL
DRYING/CLEANING MODULE
First Named Inventor: Maximilian Biberger
Domestic/Foreign Application: Domestic Application
Filing Date: 2001-04-24
Effective Receipt Date: 2003-11-14
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 6810
Attorney Docket Number: NONE
Total Fees Authorized: 180.0
Payment Category: Deposit Account
Deposit Account Number: 81275
Deposit Account Name: Thomas B. Haverstock
Access Code: *****
RAM Payment Status: RAM success
RAM User ID: EFSPROD
RAM Accounting Date: 2003-11-14
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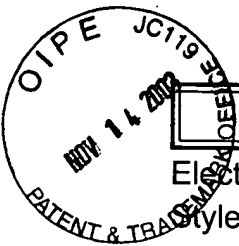
Stylesheet Version v1.1.0

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|--|---|--|-----------------------|
| Title of Invention | METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE | | |
| Application Number: 09/841800 | |  | |
| Date: 2001-04-24 | | RECEIVED NOV 18 2003 | |
| First Named Applicant: Maximilian A. Biberger | | | |
| Confirmation Number: 6810 | | | |
| Attorney Docket Number: | | | |
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| Submitted by: | | Elec. Sign. | Sign. Capacity |
| Thomas B. Haverstock Registered Number: 32571 | | /tbh/ | Attorney |
| Documents being submitted | | Files | |
| us-fee-sheet | | SSI02001A-usfees.xml | |
| | | us-fee-sheet.xsl | |
| | | us-fee-sheet.dtd | |
| us-ids | | SSI02001A-usidst.xml | |
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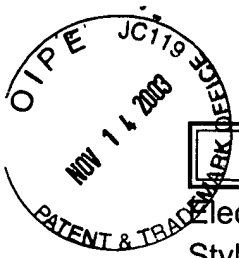


FEE TRANSMITTAL

Electronic Version v08
Stylesheet Version v08.0

| Title of Invention | METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING/CLEANING MODULE | | | | | | | | | | |
|--|--|-----------|-------------|-----------------|----------|-----------|-------------|---|------|-----|-----|
| Application Number: 09/841800  | | | | | | | | | | | |
| Date: 2001-04-24 | | | | | | | | | | | |
| First Named Applicant: Maximilian A. Biberger | | | | | | | | | | | |
| Attorney Docket Number: | | | | | | | | | | | |
| TOTAL FEE AUTHORIZED \$180 | | | | | | | | | | | |
| Patent fees are subject to annual revisions on or about October 1st of each year. | | | | | | | | | | | |
| BASIC FILING FEE | | | | | | | | | | | |
| <table border="1"><thead><tr><th>Fee Description</th><th>Fee Code</th><th>Amount \$</th><th>Fee Paid \$</th></tr></thead><tbody><tr><td>Submission Of Information Disclosure Stmt Fee</td><td>1806</td><td>180</td><td>180</td></tr></tbody></table> | | | | Fee Description | Fee Code | Amount \$ | Fee Paid \$ | Submission Of Information Disclosure Stmt Fee | 1806 | 180 | 180 |
| Fee Description | Fee Code | Amount \$ | Fee Paid \$ | | | | | | | | |
| Submission Of Information Disclosure Stmt Fee | 1806 | 180 | 180 | | | | | | | | |
| AUTHORIZED BILLING INFORMATION | | | | | | | | | | | |
| The commissioner is hereby authorized to charge indicated fees and credit any overpayments to: | | | | | | | | | | | |
| Deposit account number: 081275 | | | | | | | | | | | |
| Access Code **** | | | | | | | | | | | |
| Deposit name: Haverstock and Owens LLP | | | | | | | | | | | |
| Deposit authorized name: Thomas B. Haverstock | | | | | | | | | | | |
| Signature: /tbh/ | | | | | | | | | | | |
| Date (YYYYMMDD): 2003-11-14 | | | | | | | | | | | |
| Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17. | | | | | | | | | | | |

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Title of
Invention

METHOD OF DEPOSITING METAL FILM AND METAL
DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL
DRYING/CLEANING MODULE

Application Number: 09/841800
Date: 2001-04-24
First Named Applicant: Maximilian A. Biberger
Attorney Docket Number:



TOTAL FEE AUTHORIZED \$180

Patent fees are subject to annual revisions on or about October 1st of each year.

BASIC FILING FEE

| Fee Description | Fee Code | Amount \$ | Fee Paid \$ |
|---|----------|-----------|-------------|
| Submission Of Information Disclosure Stmt Fee | 1806 | 180 | 180 |

AUTHORIZED BILLING INFORMATION

The commissioner is hereby authorized to charge indicated fees and credit
any overpayments to:

Deposit account number: 081275

Access Code ****

Deposit name: Haverstock and Owens LLP

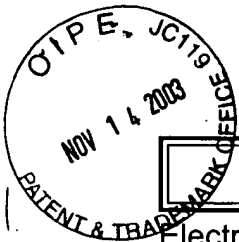
Deposit authorized name: Thomas B. Haverstock

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Date (YYYYMMDD): 2003-11-14

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Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17.



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of
Invention

METHOD OF DEPOSITING METAL FILM AND METAL
DEPOSITION CLUSTER TOOL INCLUDING
SUPERCRITICAL DRYING/CLEANING MODULE

Application Number: 09/841800



Confirmation Number: 6810

First Named Applicant: Maximilian Biberger

Attorney Docket Number:

Search string: (2439689 or 4349415 or 4925790 or 5071485
or 5196134 or 5269850 or 5285352 or
5320742).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|------------------|------|-------|----------|
| | 1 | 2439689 | 1948-04-13 | Hyde et al. | | | |
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| | 3 | 4925790 | 1990-05-15 | Blanch et al. | | | |
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| | 8 | 5320742 | 1994-06-14 | Fletcher et al. | | | |

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Remarks

Note: Remarks are not for responding to an office action.

Non US Patent and Publication references shall be filed under a separate paper transmittal. The current electronic filing contains part 1 out of a total of 5 electronic filings.

Signature

| | |
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| Examiner Name | Date |
| | |